

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination SHIH ET AL.	
		10/811,621 <i>Wong</i>	Examiner Edna Wong	Art Unit 1795

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0022963	09-2001	Klaveness et al.	424/9.6
*	B	US-6,638,621	10-2003	Anderson, David	428/402.24
*	C	US-6,689,223	02-2004	Meine et al.	134/2
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	BASF, "Surfactants: Pluronic & Tetronic" (no date), pp. 1-40.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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